

Serial No. To be assigned
Filed: July 6, 2004

Amendments to the Specification:

On page 1, after the title "**PROCESS FOR THE CHEMICAL-MECHANICAL POLISHING OF METAL SUBSTRATES**", please insert the following:

This application is a United States National Stage Patent Application under 35 U.S.C. § 371 of International Patent Application No. PCT/IB03/00535, filed February 12, 2003, which claims priority to French Patent Application No. 0201790, filed February 13, 2002, the contents of which are hereby incorporated herein by reference.